

Attorney Docket No.: 2001P05879US

\$/2625

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Jian-Feng Chen

Serial No: 09/825,783

Group Art Unit: 2625

Filed: April 4, 2001

Examiner: Patel, Jayanti K.

For: METHOD AND SYSTEM FOR IMPROVING THE SPATIAL RESOLUTION FOR STRAIN IMAGING

RECEIVED

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

APR 22 2004

Technology Center 2600

TRANSMITTAL LETTER FOR RESPONSE

Transmitted herewith in the above-identified patent application are the following:

- Amendment in response to Office Action dated January 16, 2004 and
- A new fee as calculated below:

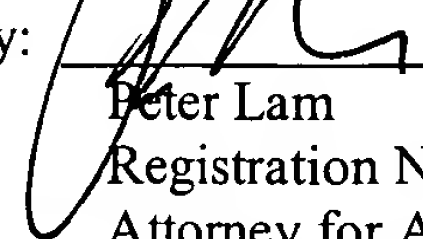
	Claims Remaining After Amendment	Number Extra	Highest Number Previously Paid For	Present Extra	Rate	Additional Fees
Total Claims	16	Minus	20	0	0 × \$18	\$0.00
Indep. Claims	8	Minus	4	4	0 × \$86	\$344.00
[ No ] First Presentation of Multiple Dependent Claim					0 × \$290	\$0
Extension Fee						\$0
Other Fees						\$0
Total Additional Fee for this Amendment						\$344.00

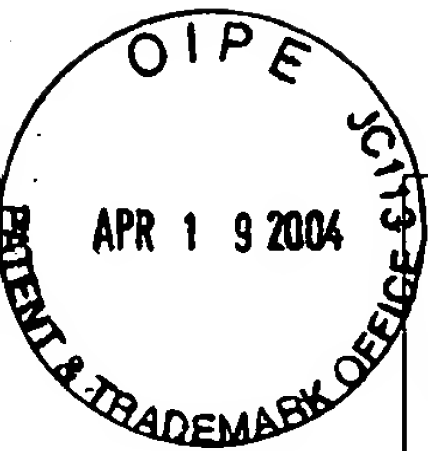
Charge any excess fees or apply any credits to Deposit Account No. 19-2179.

Date: 4/15/04

SIEMENS CORPORATION  
Intellectual Property Department  
170 Wood Avenue South  
Iselin, New Jersey 08830  
ATTENTION: Elsa Keller, IP Department  
Telephone: (732) 321-3026

Respectfully requested,

By:   
Peter Lam  
Registration No. 44,855  
Attorney for Applicants  
Tel: 650-943-7350  
Fax: 650-968-4517



#5/a  
mal  
4/30/04

CERTIFICATE OF MAIL

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on April 15, 2004.

*C. Reese*

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Date: April 15, 2004

Jian-Feng Chen

Confirmation No: 1315

**RECEIVED**

Serial No: 09/825,783

Group Art Unit: 2625

APR 22 2004

Filed: April 4, 2001

Examiner: Patel, Jayanti K.

Technology Center 2600

For: METHOD AND SYSTEM FOR IMPROVING THE SPATIAL RESOLUTION  
FOR STRAIN IMAGING

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT**

Dear Sir:

In response to the Office Action dated January 16, 2004, please amend the above-identified application in the following manner:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 10 of this paper.

**Amended Drawings** begin on page 16 of this paper.

04/20/2004 HBERHE 00000113 192179 09825783  
01 FC:1201 344.00 DA